

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

SHIMIZU et al

Atty. Ref.: 829-619

Serial No. Unknown

Group:

Filed: December 16, 2003

Examiner:

For: PLASMA CVD APPARATUS, AND METHOD FOR FORMING FILM AND
METHOD FOR FORMING SEMICONDUCTOR DEVICE USING THE SAME

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December 16, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO-1449, a copy of each of which is enclosed. This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The Examiner is requested to initial the attached form PTO-1449 and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

Respectfully submitted,

NIXON & VANDERHYE P.C.

By:



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INFORMATION DISCLOSURE CITATION	ATTY. DOCKET NO.	SERIAL NO.
	<u>829-619</u>	Unknown
	APPLICANT	
(Use several sheets if necessary)	<u>SHIMIZU et al</u>	
	FILING DATE	GROUP
	December 16, 2003	

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

*Examiner

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.